

Docket No.: M4065.0319/P319-A

(PATENT

ENEUEL 12/9/03 W/ RCE Mollish

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Husam N. Al-Shareef, et al.

Application No.: 09/912,558

Filed: July 26, 200 V

Art Unit: 2813

Examiner: Erik J. Kielin

For: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET

RAPID THERMAL OXIDATION PROCESS

AMENDMENT UNDER 37 C.F.R. § 1.116

U.S. Patent and Trademark Office 2011 South Clark Place Customer Window, MS: <u>AF</u> Crystal Plaza Two, Lobby, Room 1B03 Arlington, VA 22202

Dear Sir:

In response to the Office Action dated July 29, 2003, finally rejecting claims 13, 14, 16, 17 and 41-43, please amend the above-identified U.S. patent application as follows.

Amendments to the claims appear in the listing of claims starting on Page 2 of this paper.

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